

Notice of References Cited

Application/Control No.

10/708,532

Applicant(s)/Patent Under
Reexamination
JENSEN, KEVIN M.

Examiner

Oanh Duong

Art Unit

2155

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0154837	07-2005	Keohane et al.	711/138
*	B	US-2004/0205197 A1	10-2004	Schlereth, Michael	709/228
*	C	US-6,819,444 B1	11-2004	Yamagishi, Yoichi	358/1.15
*	D	US-2004/0205650 A1	10-2004	Cheng, Lebin	715/530
*	E	US-2003/0043844 A1	03-2003	Heller, Howard A.	370/466
*	F	US-2004/0225922 A	11-2004	Susarla et al.	714/038
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2004348766 A	12-2004	Japan	ASAHI, TSUNEMORI	
	O	JP 11055304 A	02-1999	Japan	MIYAMOTO et al.	
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.